

RESPONSE UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 2800

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Yeo, *et al.* Docket No.: TSM03-0926  
Serial No.: 10/685,938 Art Unit: 2891  
Filed: October 15, 2003 Examiner: Movva, Amar  
For: Dummy Pattern for Silicide Gate Electrode

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE UNDER 37 CFR § 1.116**

Dear Sir:

Applicants respectfully submit the following remarks in response to Examiner's Office Action dated May 13, 2008, which Action is made final. Applicants respectfully request that these remarks be entered in pursuant to the provisions of 37 CFR § 1.116, and respectfully request reconsideration of the claims.